

In The United States Patent And Trademark Office

Applicant:	Juha Maijala et al.	Date:	April 30, 2007
Date Filed:	Jan. 24, 2005	Docket No.:	METSO-24
App. No.:	10/507,437	Art Unit:	1762
For:	A Method for Forming a Film, by Using Electrostatic Forces	Examiner:	F. Parker

---

Filed by Electronic Filing System

---

**Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office action dated Jan. 10, 2007, the period for response being extended one month to May 10, 2007, by an accompanying Petition for Extension of Time, please amend the application as follows. The Commissioner is hereby authorized to charge any additional fees that may be required with respect to this communication, or credit any overpayment, to Deposit Account No. 50-2663.